

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**PATENT**

In re application of: HO et al.

Attorney Docket No.:  
LAM1P1S2D1/P0692D

Application No.: 10/762,969

Examiner: VINH, LAN

Filed: January 21, 2004

Group: 1765

Title: USE OF AMMONIA FOR ETCHING  
ORGANIC LOW-K DIELECTRICS

Confirmation No. 6351

**DECLARATION UNDER 37 CFR § 1.131**

Commissioner for Patents  
Washington, D.C. 20231

Sir:

I, Kuo-Lung Tang, declare as follows:

1. I am a named inventor for the above-mentioned case.
2. The invention in the above-mentioned case was conceived of and reduced to practice before January 26, 2001.
3. Attached is a copy of a document dated 8/1/2000 that shows results of a test that practiced the inventive etch.

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true. I further declare that these statements are made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both (under Section 1001 of Title 18 of the United States Code), and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

  
Kuo-Lung Tang

8/15/2005  
Date

Atty. Dkt. No. LAM1P130/P0566

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